



Optics Manufacturing

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Message from the Guest Editor

The aim of this Special Issues is to provide a platform for exchanging such pioneering ideas and novel approaches in optics manufacturing. This includes new insights in tool–material interactions, manufacturing-induced surface modifications, and the contamination of optical media, i.e., mainly glass. This Special Issue is thus intended to be a survey of both classical and promising novel manufacturing methods and approaches as well as an exploration of the corresponding or underlying mechanisms on the work piece surface.

- optics manufacturing
- grinding
- polishing
- lasers and plasmas
- glasses
- polymers
- micro-optics

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Editor-in-Chief

Message from the Editor-in-Chief

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